Search Notes		

Application/Control No.	Applicant(s)/Patent under Reexamination
10/692,773	LEE, HEON
Examiner	Art Unit
Eric B. Chen	1765

SEARCHED				
Class	Subclass	Date	Examiner	
216	18,22,38	6/16/2005	EC	
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
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SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
Performed inventor search for double patenting	6/16/2005	EC
EAST search	6/16/2005	EC